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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Priority** Application Serial No. .... 10/264,615  
**Priority** Filing Date .... October 3, 2002  
Inventor .... Luan C. Tran  
Assignee .... Micron Technology, Inc.  
**Priority** Group Art Unit .... 2813  
**Priority** Examiner .... Laura M. Schillinger  
Attorney's Docket No. .... MI22-2331  
Title: Semiconductor Processing Methods of Forming Integrated Circuitry

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**PRELIMINARY AMENDMENT**

To: Mail Stop Patent Application  
Commissioner for Patents  
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This Preliminary Amendment accompanies a Request for Divisional Application for the above-titled patent application. Please enter the following amendments prior to examining the above-identified application.

**AMENDMENT**

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.

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